



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoko OHTSUKI

Group Art Unit: 2828

Application No.: 10/070,684

Examiner: A. RODRIGUEZ

Filed: September 12, 2002

Docket No.: 112162

For: LASER DEVICE AND EXPOSURE METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 23, 2005 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**